Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L1	0	silicon adj4 flourine adj4 oxygen	USPAT	OR	OFF	2004/10/07 13:25
L2	77	silicon adj4 fluorine adj4 oxygen	USPAT	OR	OFF	2004/10/07 13:26
L3	11	2 and nozzle?	USPAT	OR	OFF	2004/10/07 13:28
L4	299	high adj4 density adj4 plasma and nozzle?	USPAT	OR	OFF	2004/10/07 13:29
L5	2	4 and flourine	USPAT	OR	OFF	2004/10/07 13:29
L6	152	4 and fluorine	USPAT	OR	OFF	2004/10/07 13:29
L7	130	6 and sputter? ajd4 etch?	USPAT	OR	OFF	2004/10/07 13:29
L8	49	7 and oxygen	USPAT	OR	OFF	2004/10/07 13:29
L9	27	8 and silicon	USPAT	OR	OFF	2004/10/07 13:30